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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2811
Serial No. : 09/814,255 Examiner : Ori Nadav
Filed : March 21, 2001 Confirmation No.:
Title : SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MARCH 2, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.